

L Number	Hits	Search Text	DB	Time stamp
-	56	(optical near (pick-up or pickup)) and (micromirror or micro-mirror or (micro near mirror))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 11:32
-	20	(optical near (pick-up or pickup)) and (micromirror or micro-mirror or (micro near mirror)) and perpendicular	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/12 16:30
-	58	(micromirror or micro-mirror or (micro near mirror) or microlens or micro-lens or (micro near lens)) and ((solid near immersion near lens) or SIL)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/12 16:34
-	14	(micromirror or micro-mirror or (micro near mirror) or microlens or micro-lens or (micro near lens)) same ((solid near immersion near lens) or SIL)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 11:56
-	18	(solid near immersion near lens) and ("369").clas. and (silicon near substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 11:58
-	282	(solid near immersion near lens) and ("369").clas.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 13:23
-	5	(slider near lens) and ("369").clas. and (mirror near surface)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 13:24
-	26	("369").clas. and (micro near mirror)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 13:26
-	296	(optical near (pickup or pick-up)) and ((slider near lens) or (immersion near lens) or (plano near convex) or ("near" near field))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 13:30
-	49	(optical near (pickup or pick-up)) and ((slider near lens) or (immersion near lens) or (plano near convex) or ("near" near field)) and (focusing near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 13:36
-	5047	369/44.14.ccls. or 369/44.11.ccls. or 369/112.09.ccls. or 369/112.12.ccls. or 369/112.14.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 13:37
-	19	(369/44.14.ccls. or 369/44.11.ccls. or 369/112.09.ccls. or 369/112.12.ccls. or 369/112.14.ccls.) and (plano near convex)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 13:40
-	8	(highly near reflective near coating) and (anisotropic near etching)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 14:02
-	2	(highly near reflective) and (anisotropic near etching) and ("369").clas.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 14:06
-	44	(369/44.14.ccls. or 369/44.11.ccls. or 369/112.09.ccls. or 369/112.12.ccls. or 369/112.14.ccls.) and ((immersion or immersion or immersion) near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 14:30

-	200	((immersion or immerssion or imersion or imerssion) near lens) and ("near" near field) and mirror	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 14:31
-	18	((immersion or immerssion or imersion or imerssion) near lens) and ("near" near field) and mirror and (optical near (pickup or pick-up))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 14:47
-	53	"5470627"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:11
-	311	(anisotropic near etching) same mirror	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:11
-	238	((anisotropic near etching) same mirror) and (optical)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:11
-	29	((anisotropic near etching) same mirror) same "45"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:17
-	5	((anisotropic near etching)) same "45" and "9.74"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:19
-	5	((anisotropic near etching)) and "9.74"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:19
-	30	((anisotropic near etching)) and "9.7"	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:24
-	2	(prefocus near lens) and (immersion near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:25
-	202	prefocus near lens	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:26
-	1037	optical near (pickup or pick-up) near head	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:27
-	6	(optical near (pickup or pick-up) near head) and mirror and (immersion near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:45
-	33	(optical near (pickup or pick-up)) and mirror and (immersion near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 15:55
-	131	(optical near (pickup or pick-up)) and (immersion near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 16:24
-	506	(objective near lens) same (immersion near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 16:24

-	148	((objective near lens) same (immersion near lens)) and (support)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 16:24
-	4	((objective near lens) same (immersion near lens)) and (support near frame)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 16:33
-	2	((objective near lens) same (immersion near lens)) and (supporting near frame)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 16:34
-	2394	((objective or object) near lens) with (frame)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 16:34
-	8	((objective or object) near lens) with (frame)) and (immersion near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 16:36
-	40	((objective or object) near lens) with (support or supporting)) and (immersion near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/13 16:37
-	120	(369/300.ccls. or 369/13.33.ccls. or 369/112.29.ccls. or 369/112.24.ccls.) and ((immersion near lens) or (slider near lens))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 14:10
-	9	(369/300.ccls. or 369/13.33.ccls. or 369/112.29.ccls. or 369/112.24.ccls.) and ((immersion near lens) or (slider near lens)) and (silicon near substrate)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 11:59
-	2	5689480.pn.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 11:51
-	2	(369/300.ccls. or 369/13.33.ccls. or 369/112.29.ccls. or 369/112.24.ccls.) and ((immersion near lens) or (slider near lens)) and (silicon near wafer)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 12:03
-	7	(369/300.ccls. or 369/13.33.ccls. or 369/112.29.ccls. or 369/112.24.ccls.) and (koh or adp or tmah)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 12:41
-	667	369/300.ccls. or 369/13.33.ccls. or 369/112.29.ccls. or 369/112.24.ccls.	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 14:10
-	85	(369/300.ccls. or 369/13.33.ccls. or 369/112.29.ccls. or 369/112.24.ccls.) and (air-bearing or (air near bearing))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 14:11
-	48	(369/300.ccls. or 369/13.33.ccls. or 369/112.29.ccls. or 369/112.24.ccls.) and (air-bearing or (air near bearing)) and (immersion near lens)	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 14:19
-	6	(369/300.ccls. or 369/13.33.ccls. or 369/112.29.ccls. or 369/112.24.ccls.) and (air-bearing or (air near bearing)) and (immersion near lens) and (mirror same (coating or coated))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/17 14:25
-	22	(369/300.ccls. or 369/13.33.ccls. or 369/112.29.ccls. or 369/112.24.ccls.) and ((micro near4 mirror) or (micro-mirror))	USPAT; US-PGPUB; EPO; JPO; DERWENT	2003/11/18 09:41